

Docket No.: EHF 2001,0167 P

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Norbert Benesch et al.
Applic. No. : 09/873,230
Filed : June 4, 2001
Title : Method and Device for Optically Monitoring Fabrication
Processes of Finely Structured Surfaces in a Semiconductor
Production

ASSOCIATE POWER OF ATTORNEY

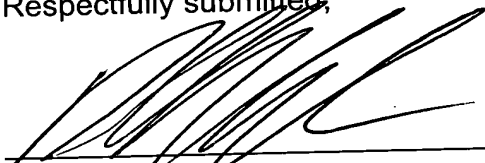
Hon. Commissioner of Patents and Trademarks,
Washington, D.C. 20231

Sir:

Please recognize MARK P. WEICHSELBAUM (Reg. No. 43,248) as my associate in the matter in the above-identified application, with full powers. Please continue addressing all communications to the following address:

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Respectfully submitted,


For Applicants

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Date: August 17, 2001

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